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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2123
PATENT**

Customer No. 22,852
Attorney Docket No. 4329.2612-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Ryoichi Inanami et al.)	Group Art Unit: 2123
)	
Application No.: 09/912,398)	Examiner: Stevens, Thomas H.
)	
Filed: July 26, 2001)	
)	Confirmation No.: 5029
For: METHOD AND SYSTEM FOR)	
PRODUCING SEMICONDUCTOR)	Mail Stop AF
DEVICES)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In response to the final Office Action dated June 30, 2005, the period for response to which extends through September 30, 2005, and pursuant to 37 C.F. R. § 1.116, Applicants propose to amend this application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.

Attachments to this amendment include an English language translation of Japanese Patent Application No. 2000-227324, filed in Japan on July 27, 2000.